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684.2864

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MITSURO SUGITA, ET AL.)
Appln. No.: 09/337,040)
Filed: June 28, 1999)
For: MULTIPLE EXPOSURE)
METHOD)
Examiner: S. Mohamedulla
Group Art Unit: 1756
August 17, 2000

The Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

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Sir:

Applicants respectfully traverse the restriction requirement set forth in the Office Action dated July 18, 2000.

In the Office Action, the Examiner sets forth a restriction requirement between two groups of claims. Group I, claims 1 through 12, 26 through 37, 51 through 62, 76 through 82 and 84, is directed to an exposure method, classified in class 430, subclass 311. Group II, claims 13